



Patent  
Attorney's Docket No. 027260-295

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of	)	<b>MAIL STOP AF</b>
	)	
Kazuya KAMON	)	Group Art Unit: 1756
	)	
Application No.: 09/320,946	)	Examiner: S. Mohamedulla
	)	
Filed: May 26, 1999	)	Confirmation No.: 5658
	)	
For: PHOTOMASK, FABRICATION	)	
METHOD OF PHOTOMASK, AND	)	
FABRICATION METHOD OF	)	
SEMICONDUCTOR INTEGRATED	)	
CIRCUIT	)	

**AMENDMENT UNDER 37 C.F.R. §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: November 10, 2003

Sir:

This Amendment responds to the Office dated August 13, 2003 (Paper No. 23).

Please amend the above-identified application as follows:

11/12/2003 HDEMESS1 00000095 09320946

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